



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 19, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

GRADING RESULTS

CARAT WEIGHT

COLOR GRADE

CLARITY GRADE

ADDITIONAL GRADING INFORMATION

POLISH

SYMMETRY

FLUORESCENCE

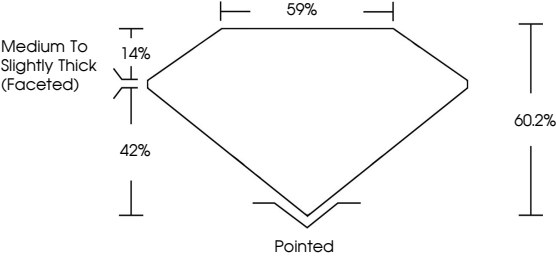
INSCRIPTION(S)

COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG811691125

Report verification at [igi.org](#)

PROPORTIONS

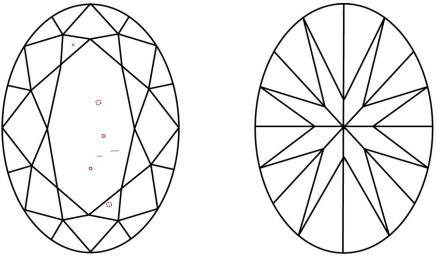


Medium To Slightly Thick (Faceted)



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

FL D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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LABORATORY GROWN DIAMOND

OVAL BRILLIANT

11.66 X 8.21 X 4.94 MM

3.02 CARATS

D

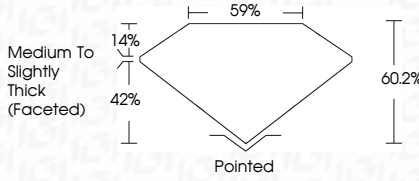
VS 2

EXCELLENT

EXCELLENT

NONE

IGI LG811691125



Medium To Slightly Thick (Faceted)

IGI



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June 19, 2026

IGI Report No LG811691125

OVAL BRILLIANT

11.66 X 8.21 X 4.94 MM

3.02 CARATS

D

VS 2

60.2%

59%

Medium to Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG811691125

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